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CONFIRMATION NO. 1775

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|---|---|----------------------------------|---|--------------------------------------|--------------------------------|
| SERIAL NUMBER 10/776,338 | FILING OR 371(c) DATE 02/12/2004 RULE | CLASS 257 | GROUP ART UNIT 2814 | ATTORNEY DOCKET NO. 01-549 | |
| APPLICANTS Rajesh Kumar, Nagoya-city, JAPAN; Florin Udrea, Cambridge, UNITED KINGDOM; Andrei Mihaila, Cambridge, UNITED KINGDOM; | | | | | |
| ** CONTINUING DATA ***** <div style="text-align: right;"><i>NONE, PC</i></div> | | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2003-35404 02/13/2003 <i>yes, PC</i> | | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/16/2004 | | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>Carmen M. PC</i> Allowance Examiner's Signature Initials | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 9 | TOTAL CLAIMS 19 | INDEPENDENT CLAIMS 3 |
| ADDRESS 23400 | | | | | |
| TITLE Semiconductor device provided by silicon carbide substrate and method for manufacturing the same | | | | | |
| FILING FEE RECEIVED 900 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |